



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 17, 2026

IGI Report Number

LG816675281

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE BRILLIANT

Measurements

11.34 X 4.88 X 3.11 MM

GRADING RESULTS

Carat Weight

1.01 CARAT

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

VERY GOOD

Symmetry

VERY GOOD

Fluorescence

NONE

Inscription(s)

 LG816675281

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LABORATORY GROWN DIAMOND REPORT



July 17, 2026

IGI Report Number

LG816675281

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE BRILLIANT

Measurements

11.34 X 4.88 X 3.11 MM

GRADING RESULTS

Carat Weight

1.01 CARAT

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

VERY GOOD

Symmetry

VERY GOOD

Fluorescence

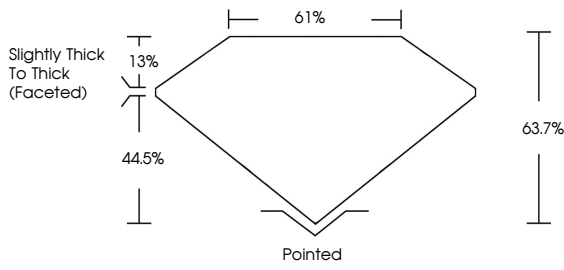
NONE

Inscription(s)

 LG816675281

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Slightly Thick To Thick (Faceted)

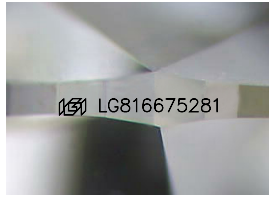
61%

13%

44.5%

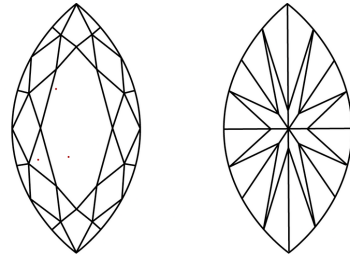
63.7%

Pointed



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



© IGI 2020, International Gemological Institute

FD - 10 20



IGI

July 17, 2026

IGI Report No LG816675281

MARQUISE BRILLIANT

11.34 X 4.88 X 3.11 MM

Carat Weight

1.01 CARAT

Color Grade

E

Clarity Grade

VVS 2

Depth

63.7%

Girdle

61%

Slightly Thick To Thick (Faceted)

Pointed

Culet

VERY GOOD

Polish

VERY GOOD

Symmetry

VERY GOOD

Fluorescence

NONE

Inscription(s)

 LG816675281

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa